

Form PTO-1449

Docket Number 404302000800

Application Number 10/014,290

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

Applicant

Filing Date December 10, 2001

Mailing Date April 10, 2002

Kyoung MIN et al.

Group Art Unit 2871

TECHNOLOGY CENTER 2800

U.S. PATENT DOCUMENTS

Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate
JDG	1.	09/08/1970	3,527,535	Monroe	—	—	
JDG	2.	11/06/1973	3,771,124	McMahon	—	—	
JDG	3.	02/04/1975	3,864,042	Leventhal	—	—	
JDG	4.	08/17/1976	3,975,711	McMahon	—	—	
JDG	5.	10/17/1978	4,120,585	DePalma et al.	—	—	
JDG	6.	01/16/1979	4,135,147	Riganati et al.	—	—	
JDG	7.	07/01/1980	4,210,899	Swonger et al.	—	—	
JDG	8.	07/20/1982	4,340,300	Ruell	—	—	
JDG	9.	11/08/1983	4,414,684	Blonder	—	—	
JDG	10.	05/26/1987	4,668,995	Chen et al.	—	—	
JDG	11.	07/21/1987	4,681,435	Kubota et al.	—	—	
JDG	12.	05/23/1989	4,832,485	Bowles	—	—	
JDG	13.	10/03/1989	4,872,203	Asai et al.	—	—	
JDG	14.	01/08/1991	4,983,415	Arndt et al.	—	—	
JDG	15.	09/24/1991	5,051,576	Schiller	—	—	
JDG	16.	03/17/1992	5,096,290	Ohta	—	—	
JDG	17.	04/28/1992	5,109,427	Yang	—	—	
JDG	18.	01/05/1993	5,177,435	Kiyokawa et al.	—	—	
JDG	19.	01/05/1993	5,177,802	Fujimoto et al.	—	—	
JDG	20.	02/23/1993	5,189,482	Yang	—	—	
JDG	21.	05/11/1993	5,210,588	Lee	—	—	
JDG	22.	06/22/1993	5,222,153	Beiswenger	—	—	
JDG	23.	08/03/1993	5,233,404	Lougheed et al.	—	—	
JDG	24.	05/16/1995	5,416,573	Sartor, Jr.	—	—	
JDG	25.	11/14/1995	5,467,403	Fishbine et al.	—	—	
JDG	26.	08/20/1996	5,548,394	Giles et al.	—	—	

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JDG	27.	04/15/1997	5,621,516	Shinzaki et al.	—	—	
JDG	28.	04/22/1997	5,623,553	Sekiya	—	—	
JDG	29.	06/03/1997	5,635,723	Fujieda et al.	—	—	
JDG	30.	10/21/1997	5,680,205	Borza	—	—	
JDG	31.	03/24/1998	5,732,148	Keagy et al.	—	—	
JDG	32.	04/07/1998	5,737,071	Arndt	—	—	
JDG	33.	04/14/1998	5,740,276	Tomko et al.	—	—	
JDG	34.	08/18/1998	5,796,858	Zhou et al.	—	—	
JDG	35.	09/22/1998	5,812,252	Bowker et al.	—	—	
JDG	36.	10/13/1998	5,822,445	Wong	—	—	
JDG	37.	11/17/1998	5,838,206	Busca et al.	—	—	
JDG	38.	02/23/1999	5,875,025	Toyoda et al.	—	—	
JDG	39.	10/05/1999	5,963,657	Bowker et al.	—	—	
JDG	40.	11/23/1999	5,991,431	Borza et al.	—	—	
JDG	41.	11/28/2000	6,154,285	Teng et al.	—	—	
JDG	42.	11/27/2001	6,324,020	Teng et al.	—	—	

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Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation and/or Abstract	
							YES	NO
JDG	43.	07/03/1986	JP 61-145686 A	Japan	—	—	Abstract	
JDG	44.	10/02/1986	JP 61-221883 A	Japan	—	—	Abstract	
JDG	45.	04/04/1987	JP 62-74177 A	Japan	—	—	Abstract	
JDG	46.	03/22/1989	0 308 162 A2,3	Europe	—	—		
JDG	47.	05/23/1990	JP 2-133892 A	Japan	—	—	Abstract	
JDG	48.	07/24/1990	JP 2-188888 A	Japan	—	—	Abstract	
JDG	49.	04/22/1991	JP 3-95693 A	Japan	—	—	Abstract	
JDG	50.	09/07/1991	1,286,032	Canada	—	—		
JDG	51.	11/05/1991	JP 3-246693 A	Japan	—	—	Abstract	
JDG	52.	12/24/1991	JP 3-292578 A	Japan	—	—	Abstract	

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53.	08/27/1993	JP 5-216981	Japan	_____	_____	Abstract	
54.	08/13/1994	KR 9407344	Korea	_____	_____	Abstract & Translation	
55.	10/05/1994	0 617 919 A2,3	Europe	_____	_____		
56.	05/19/1995	JP 7-131322	Japan	_____	_____	Abstract	
57.	09/19/1996	DE 195 09 751 A1	Germany	_____	_____	Abstract	
58.	04/17/1997	WO 97/14111 A1	WIPO	_____	_____		
59.	03/19/1998	WO 98/11478 A2	WIPO	_____	_____		
60.	03/19/1998	WO 98/11501 A2,3	WIPO	_____	_____		
61.	03/19/1998	WO 98/11750 A2	WIPO	_____	_____		
62.	06/10/1998	EP 0 847 024 A2,3	Europe	_____	_____		
63.	08/13/1998	WO 98/35118 A1	WIPO	_____	_____	Derwent Abstract	
64.	09/30/1998	EP 0 867 828 A2,3	Europe	_____	_____		
65.	09/30/1998	EP 0 867 829 A2,3	Europe	_____	_____		
66.	04/13/1999	JP 11-102432	Japan	_____	_____	Abstract	
67.	02/17/2000	WO 00/08591	WIPO	_____	_____		
68.	05/18/2000	WO 00/28469	WIPO	_____	_____		
69.	06/29/2000	WO 00/38099	WIPO	_____	_____		

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(including author, title, Date, Pertinent Pages, Etc.)

Examiner Initials	Ref. No.	Title
JDB	70.	Seigo Igaki et al. (1990). "Holographic Fingerprint Sensor," <i>FUJITSU-Sci. Tech. J.</i> 25(4):287-296.

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